

## LiteScope<sup>TM</sup> Technical Specification

## Enviromental

Operating temperature +1	$5^{\circ}$ C to $+25^{\circ}$ C	
Operating pressure 10	<sup>-5</sup> Pa to 10 <sup>5</sup> Pa	
Dry environment only		

## **Mechanical**



Weight	650 g
Maximal scanned sample area	$22 \text{ mm} \times 11 \text{ mm} \times 8 \text{ mm}$
Coarse approach	True orthogonal positioning Calibrated, pre-stressed linear ball bearings Self-locking Minimum incremental motion 50 nm Speed >2 mm/s X travel range 24 mm, Y travel range 12 mm Z travel range 12 mm (Open Loop), 10 mm (Closed Loop)
Scanning unit	Based on multi-layer, low-voltage piezoelectric transducer Solid state flexure guide system Open Loop/Closed Loop XYZ-axis movement 100 µm (Open Loop), 80 µm (Closed Loop) Resolution 0.2 nm (Open Loop), 2 nm (Closed Loop)
Fast and easy probe exchange	Universal acceptor for different probes Four standard probe holders
Sample holder for SEM stubs ( $\emptyset$ 12.7 mm with $\emptyset$ 3.2 mm and 4.6 mm long pin)	Two additional positions for SEM/FIB imaging/machining (not to be measured by SPM)



Tel.: +49-(0)6103-30098-0 Fax: +49-(0)6103-30098-29

Schaefer Technologie GmbH · Robert-Bosch-Str. 31 · D-63225 Langen E-Mail: info@schaefer-tec.com Web: www.schaefer-tec.com

## Operation and control system

Operation and control system			
Modes of operation	AFM - contact, AFM - request, MFM - on requ	tapping, C-AFM - on request, EFM - on request, est	STM - on
Probes	Akiyama probe, Tuning-	fork based probes, Piezoresistive probes, NenoProb	es, etc.
Maximal frequency of PLL for dynamic mea	asurements 75 kHz (Higher	PLL frequency on request)	
$2{\times}16$ bit DAC per scan axis (scan range, o	ffset) to reach maximal res	olution everywhere within the view field	
	100 µm (<2 nm)		
User selectable piezo amplifier gain	50 µm (<1 nm)		
scan range (vs. resolution)	10µm (<0.2 nm)		
and a series of the series of	5µm (<0.2nm)		
$5{\times}16$ bit auxiliary inputs for simultaneous $\tau$	measurements of user signa	ls (±10V)	
Input channels could be used in feedback-lo	рор		
Probe signal output/monitor			
External probe excitation			
All necessary connections for using external	I PLL		
Ethernet connection to the control PC	RISEN -		
110 VAC/230 VAC operation, 200 W			
Softwara			
Soltware			
Web based user interface			
Easy for new users, flexible for experts			
User accounts	Every user has an account Accounts individually configurable – layout, parameters, complexity,		
Remote access to the user data, download	of data from control PC to	the local workstation	
Remote experiment control via eg. tablet, s	smart-phone		

Integrated data post-processing, analysis, export, etc.





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